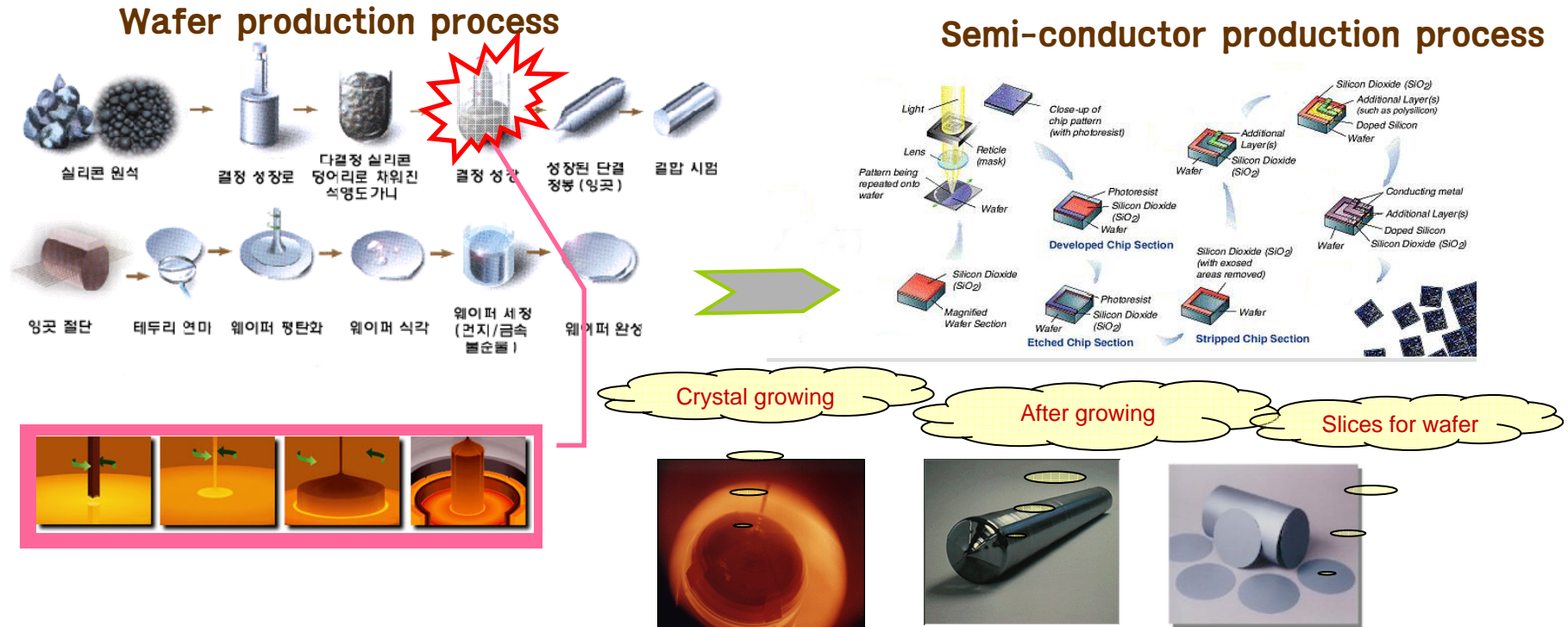


# Improvement of Industrial Control System for Single Crystal Grower for Semiconductor Wafer Production

with LG Siltron



## ● Objective

- Need more tight and precise control for large diameter (300mm) and high quality wafer demand.
- With minimum changes in existing hardware/software system